## 10/571142 IAP9 ROCUPCT/PTO 09 MAR 2006

**PATENT** 

ATTORNEY DOCKET NO.: 46884-5461

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Kenshi FUKUMITSU et al.		) Confirmation No.: Unassigned
	nal Stage of International Application PCT/JP2004/013163 filed Sept. 9, 2004	)
	d: March 9, 2006	) Group Art Unit: Unassigned )
For:	SEMICONDUCTOR SUBSTRATE CUTTING METHOD	) Examiner: Unassigned )
Comm	hissioner for Patents	

MAIL STOP PCT

Sir:

## **PRELIMINARY AMENDMENT**

Prior to examination on the merits, please amend the above-identified application as follows.